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CONFIRMATION NO. 3943

SERIAL NUMBER 10/628,001	FILING OR 371(c) DATE 07/25/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. AMAT/7938/ETCH/SILICON/JB		
APPLICANTS Matthew F. Davis, Brookdale, CA; Lei Lian, Santa Clara, CA; <i>PS</i> ** CONTINUING DATA ***** <i>No</i> <i>PS</i> ** FOREIGN APPLICATIONS ***** <i>No</i>						
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/10/2004						
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance		STATE OR COUNTRY CA	SHEETS DRAWING 11	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 3	
Verified and Acknowledged <i>Charles Thomas</i> Examiner's Signature		Initials				
ADDRESS 44182						
TITLE Method for automatic determination of semiconductor plasma chamber matching and source of fault by comprehensive plasma monitoring						
FILING FEE RECEIVED 1638	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		